

10/532249

JCO5 Rec'd PCT/PTO 22 APR 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Kenji MARUYAMA, et al.**

Serial Number: **Not Yet Assigned**
(§371 of International Application PCT/JP03/14123)

Filed: **April 22, 2005**

For: **METHOD OF PRODUCING SEMICONDUCTOR DEVICE**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 22, 2005

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449 and cited in the enclosed international search report. References AA and AE-AH are cited in the international search report.

A copy of each of the references, except for the U.S. patent reference, is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,
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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; References (5); International Search Report

INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 050256	Serial No. 10/532249 New Application
	Applicant(s): Kenji MARUYAMA, et al.	
	Filing Date: April 22, 2005	Group Art Unit: Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA	6,333,202	J.W. Adkisson, et al.			12/25/01
_____	AB					

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
_____	AC	2001-102543	04/13/01
_____	AD	Japan	Yes-Abstract/Discussed in the specification

OTHER DOCUMENTS

_____	AE	Patent Abstracts of Japan, Publication Number 8-186235, dated July 16, 1996.
_____	AF	Patent Abstracts of Japan, Publication Number 8-227980, dated September 3, 1996.
_____	AG	L. Tsakalakos, et al.; "Excimer Laser Liftoff of Epitaxial Pb(Zr, Ti)O ₃ Thin Films and Heterostructures;" <i>Mat. Res. Soc. Symp. Proc.</i> ; Vol. 596; 2000; pp. 549-556.
_____	AH	B. K. Moon, et al.; "Characteristics of ferroelectric Pb(Zr,Ti)O ₃ films epitaxially grown on CeO ₂ (111)/Si(111) substrates; <i>Thin Solid Films</i> ; Vol. 385; 2001; pp. 307-310.
Examiner _____ Date Considered _____		